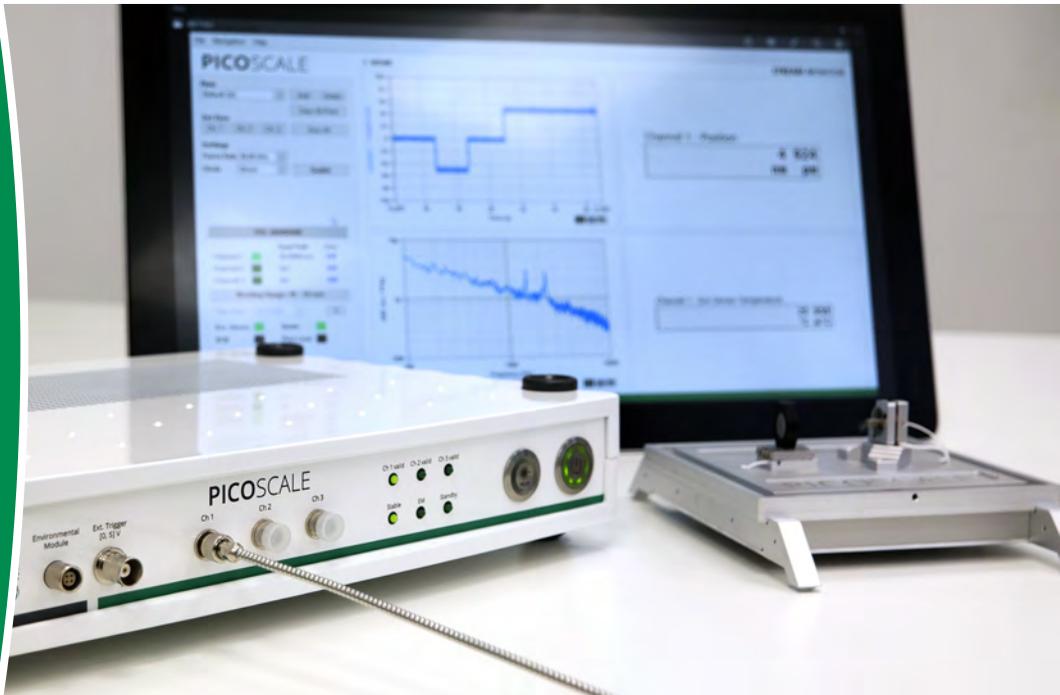


Metrology





Metrology 2019

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The information given in this catalog was carefully checked. Nevertheless it is not possible to fully exclude the presence of errors. In order to always receive the latest information and specifications regarding our products, please contact our technical sales team or visit smaract.com

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Your Partner for High Precision in Positioning and Metrology.

SmarAct Services

Customer Service

Our sales team consists of experts with technical backgrounds in fields such as physics, material science, optics and life science and are looking forward to support you in selecting the best solution for your positioning and measurement task. We have unrivaled speed and flexibility in developing and building custom solutions according to your specific requirements – no matter whether it is a highly complex or a recurrent high-volume OEM positioning system.

Service and Support

As part of a fully customer oriented company, the SmarAct Sales and Support Team is pleased to help and support you during the installation and setup of your new positioning system. The team also offers immediate and comprehensive technical support to minimize downtime of your application.

Customization and Engineering Service

You have a new challenging task within the field of positioning or metrology? Parts and components presented in this catalog generally caught your attention but did not quite match your specific criteria? Just involve us. We are eager to hear about your project and design the perfect solution for it.

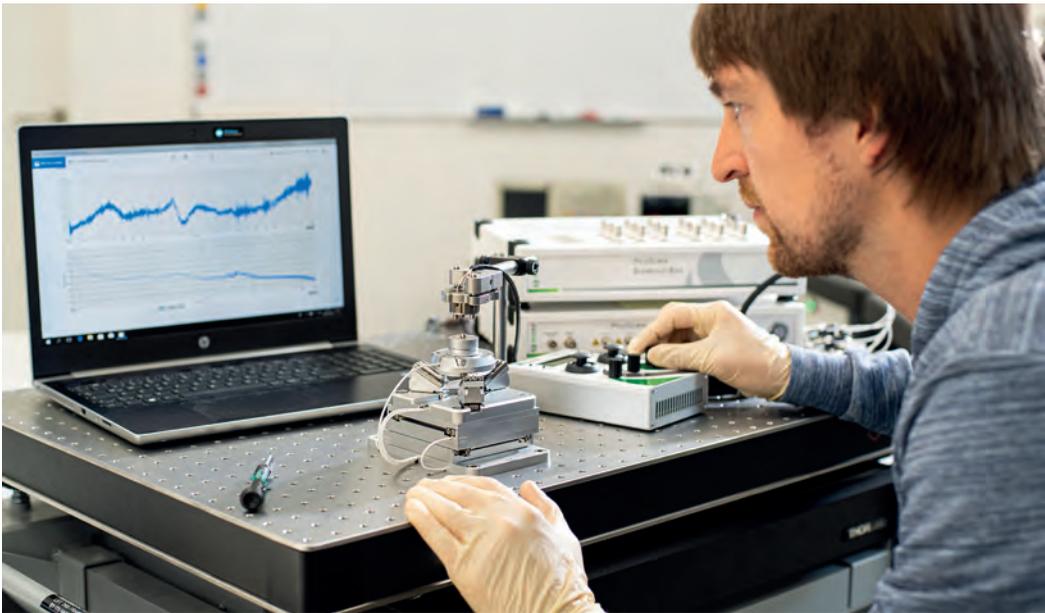
Equipment Rental Service

You only need a certain SmarAct product for a short period of time? Many of our positioning and metrology systems can be rented. Please check with our technical sales team for rental terms, conditions and product availability.

Commitment to Quality

We are certified according to the ISO standard 9001:2015 and eager to deliver the best solutions and products for laboratory and industry applications.





Laboratory Measurement Services

The nature of some projects does not justify the investment in specialized instrumentation and knowledge. To meet this situation, SmarAct offers laboratory measurement services, which enables you to add state-of-the-art metrology approaches to your project.

Your Advantages

- Benefit from the latest equipment and expertise
- Get faster approval for engineering services as opposed to an investment in technology
- Evaluate the impact of new measurement capabilities prior to an investment decision
- Simplify your development process by outsourcing specific measurement tasks

Take the next step

Our measurement services can help you to optimize your development process but also to solve a one-off problem that limits the performance of your product. The measurement services are performed at our laboratories in Germany but can also be carried out on site. Please contact us to discuss your requirements and plan a pilot study today.

Laser Scanning Vibrometry

Employ the latest laser scanning vibrometry technology to characterize the vibrational modes of your devices.

Typical customer applications:

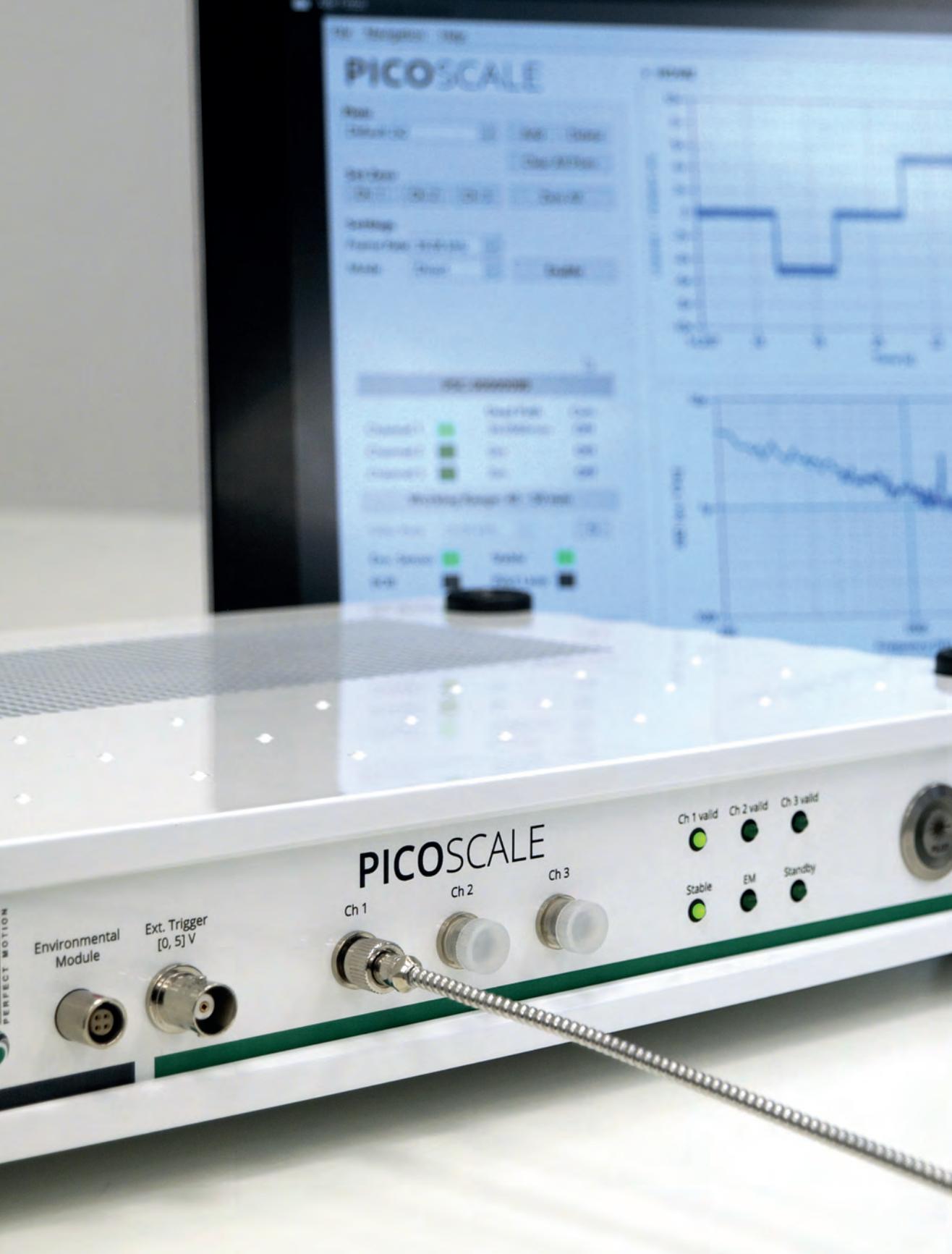
- MEMS
- Voice coil motors
- Transducers
- Loudspeakers
- Hearing aids
- Acoustofluidic devices
- Noise source identification for microscopy (AFM, EM)

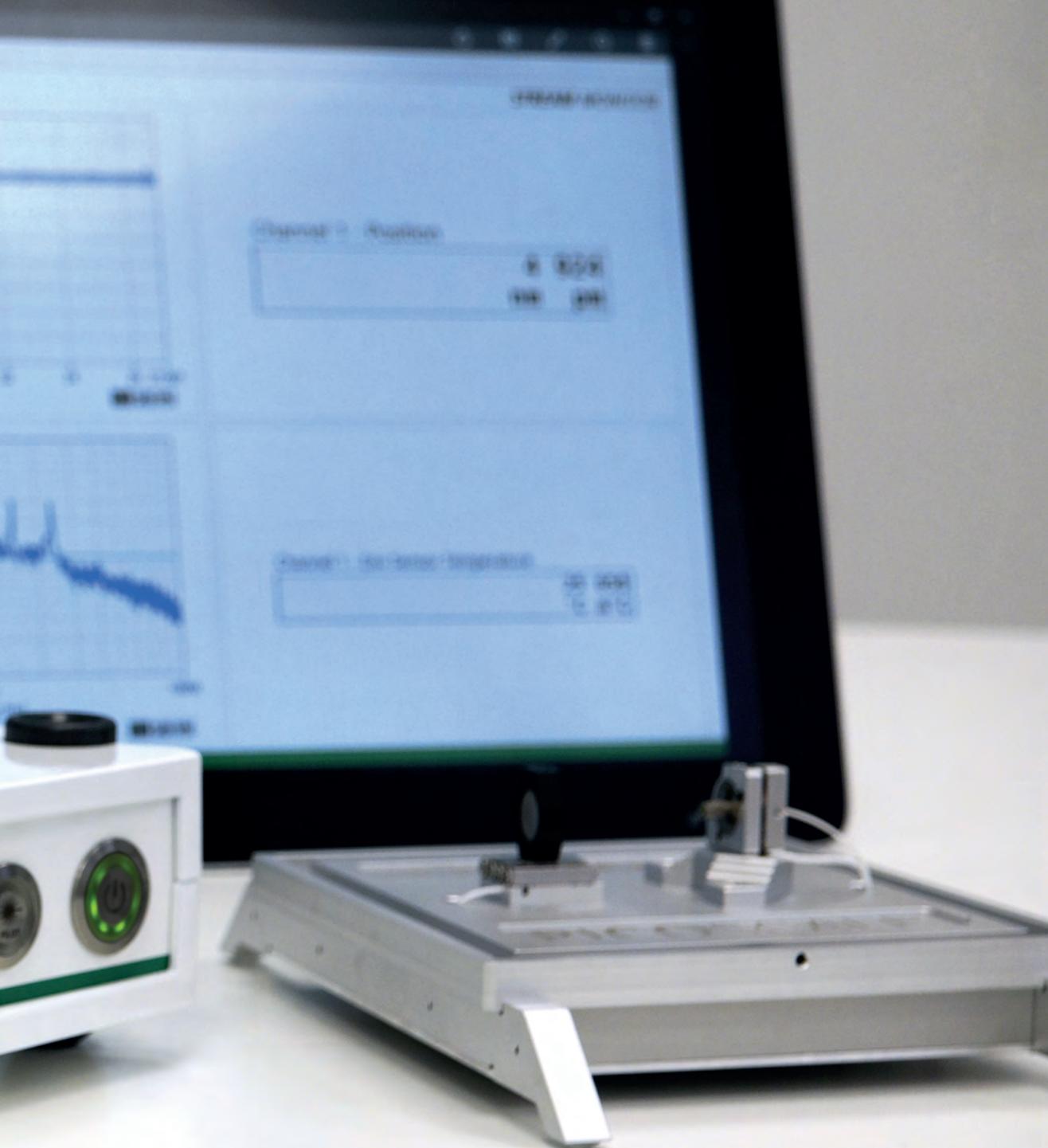
Motion Analysis

Parallel measurements with interferometry enable the multi-dimensional analysis of motion systems at unsurpassed resolution. The results allow to characterize, validate and to improve motion.

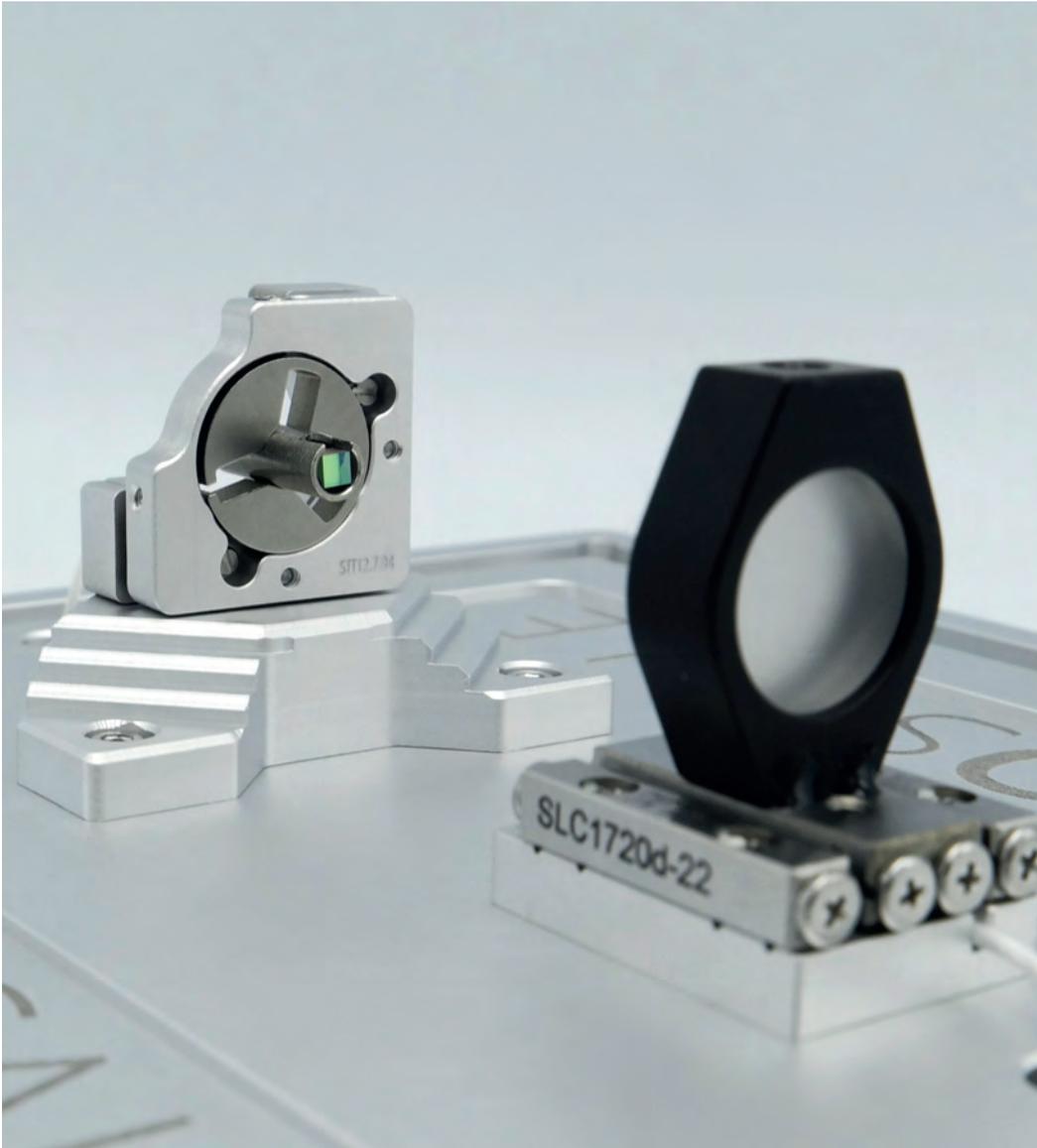
Typical customer applications:

- Calibration and validation of motion systems
- Repeatability and accuracy
- Thermal stability
- Tip/tilt of a target during translation
- Radial run-out of a rotating system





Interferometric Solutions



SmarAct's Interferometric Solutions for Metrology

Today's standards in manufacturing, quality control and research require methods to measure distances and displacements at the highest possible accuracy. SmarAct offers a range of metrology solutions to help you characterizing and improving your processes.

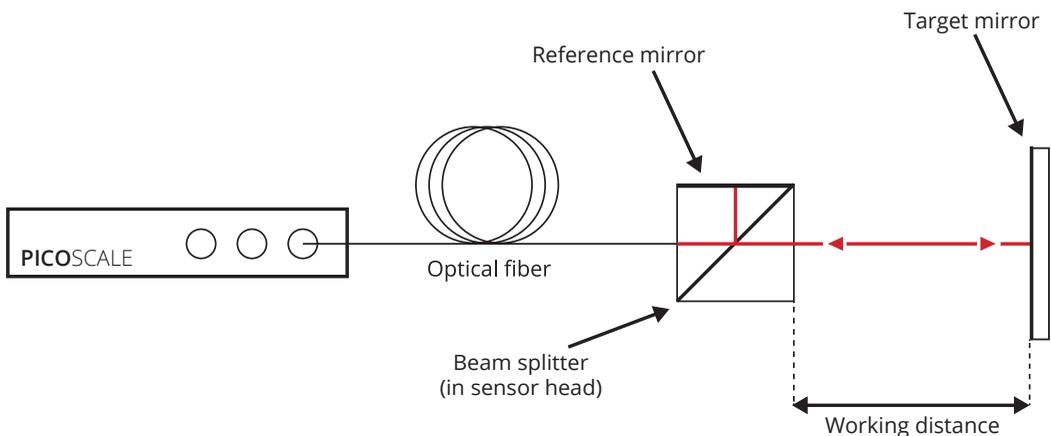
SmarAct's **PICOSCALE** products are based on optical methods for the contactless measurement of displacements and vibrations. Because no physical contact is required, the objects will not be affected by the measurement. This is especially relevant for smaller objects, whose dynamics are easily influenced by the attachment of conventional measurement probes.

The **PICOSCALE Interferometers** are widely used in positioning technology and allow tracking of displacements at pm resolution. A variety of sensor heads have been developed to adapt the measurement to your exact requirements. This includes the operation at different distances, on different samples but also the measurement of angles. Special sensor heads are available for extreme conditions such as cryogenics, high radiation and vacuum.

Beyond measuring displacements, **PICOSCALE Interferometers** are used for the characterization of the dynamic performance during motion. Because the positional data is measured at a very high bandwidth, vibrations can be accurately identified in real time. For detailed modal analyses, SmarAct offers the **PICOSCALE Vibrometer**. Here, the interferometer probe beam is raster-scanned

over the sample and the frequency response is accurately determined at up to 1 million measurement positions.

The **PICOSCALE Vibrometer** is a turnkey solution to measure vibrations of micromechanical structures with sizes that range from just a few μm up to several cm. Applications include the testing of MEMS, miniature loudspeakers and microphones but also actuators and transducers. Because the instrument is equipped with an integrated megapixel microscope, it is excellently suited to visualize vibrational modes at high spatial and temporal resolution.



The Core Technology: Interferometry

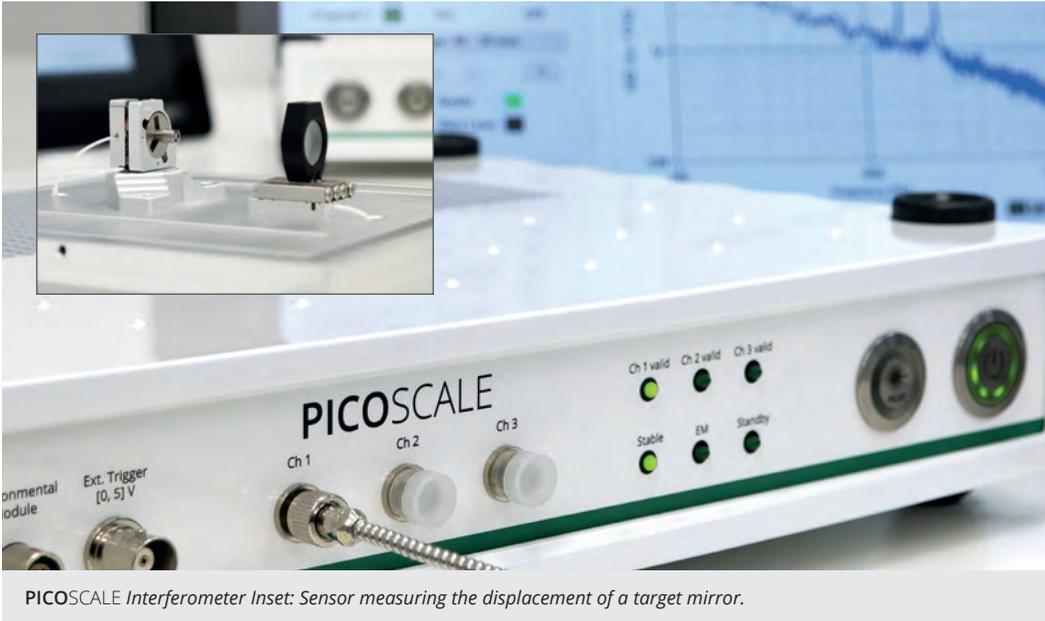
All **PICOSCALE** products are based on a Michelson interferometer, a precise method to measure displacements and vibrations. The Michelson interferometer consists of a wavelength-stabilized laser, a beam splitter, a target and a reference mirror.

At the beam splitter, the light from the laser is divided into two arms. One arm is directed to the target surface while the other is directed to the reference mirror. After the light of both arms is reflected by the target surface and reference mirror, respectively, it travels back to the beam splitter. Here, both arms recombine and interference takes place.

The interference signal contains information on the displacement of the target surface with respect to the reference mirror.

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Measuring Displacements - PICOSCALE Interferometer



PICOSCALE Interferometer Inset: Sensor measuring the displacement of a target mirror.

PICOSCALE Interferometer

For high precision displacement measurements, SmarAct offers the **PICOSCALE Interferometer**, a powerful sensor with picometer resolution. Based on an extremely compact Michelson interferometer, non-invasive measurement with low restrictions on the target reflectivity can be realized very efficiently.

Sensor heads are available for general purpose or optimized for specific tasks like angular or differential measurements. Furthermore, we provide sensor heads for use in vacuum, cryogenic or other harsh environments. Due to their compactness, they fit into almost every setup.

Powerful firmware modules and versatile accessories complement the **PICOSCALE** portfolio to emphasize its use as a laboratory device for synchronization with other devices, signal generation, real-time calculation and many more applications.

Key Features	
Resolution [pm]	1
Number of Channels	3
Working Distance [mm]	0 ... 1000
Maximum Target Velocity [m/s]	2
Data Rate [MHz]	Up to 10
Measurement Laser Wavelength [nm]	1550, laser class 1
Pilot Laser Wavelength [nm]	650, laser class 1
Measurement Conditions	Ambient, high vacuum, ultra-high vacuum, cryogenics, hard radiation
GPIO Interface	3 x ADC, 5 x DAC, Serial data, AquadB
Controller Chassis	33 x 27 x 7.2 cm, weight 3.5 kg (tabletop) 48.2 x 31 x 4.5 cm, weight 3.8 kg (19" rack)



Selection of sensor heads

About PICO SCALE Sensor Heads

The **PICO SCALE** sensor heads are mandatory equipment to perform high resolution displacement measurements. Within the heads, the probe and the reference beam interfere, and the interference pattern contains the information on the target mirror's position. Currently, SmarAct offers three classes of sensor heads with different beam geometries that were designed for a great variety of applications.

Customization

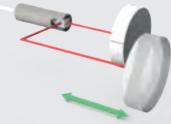
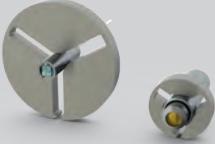
Since SmarAct designs and manufactures all products in-house, we can efficiently design and produce customized sensor heads. This includes integration of **PICO SCALE** sensor heads into SmarAct's motion systems and customized solutions with specific properties according to your needs. Please contact SmarAct's direct and flexible customer support.

	C01	C02	C03	F01	L01
Beam Geometry	Collimated			Focused	Line Focused
Focal Distance [mm]	-			10*	30 or 50
Beam Waist Diameter [μm]	400	1520	1590	28*	50 x 1590
Working Distance [mm]	13 ... 650	0 ... 1000	0 ... 500	10 ± 0.5*	30 ± 10
Angular Working Range [°]	± 0.05	± 0.013	± 0.013	± 2*	± 1.3 (focused axis) ± 0.05 (collimated axis)
Dimensions [mm]	4 x 13	9 x 23	6 x 21	6 x 21	9 x 26
Conditions	Air, HV, UHV, CRYO	Air, HV, UHV			
Typical Targets	Mirror	Mirror/Retro-Reflector		Small samples	Cylindrical samples

** for a sensor head with 10 mm focal distance. Focal distance can be selected between 8 and 30 mm.*

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Measuring Displacements - Sensor Head Options and Accessories

Sensor Head Options	
	<p>Several sensor heads are available for different environments such as ambient air, ultra-high vacuum, cryogenic or hard radiation.</p>
	<p>For C01 sensor heads different beam splitter cubes are available:</p> <ul style="list-style-type: none"> • Standard: The reference mirror is directly coated to the side surface. • Front reference: The reference mirror is coated to the front surface so that the measurement beam exits perpendicularly. • External reference: Without coating, differential displacement measurements become possible (see picture).
	<p>The sensor heads are connected to the controller by optical glass fibers. In addition to our standard polyamide fibers we offer a robust metal shielding (see picture), PTFE for UHV and radiation resistant PEEK tubing.</p>
Mounting Accessories	
	<p>We offer adapter plates for all sensor heads to fix them in conventional 1/2" or 1" mounts. The sensor head is automatically secured in the adapter when it is fastened in a mount.</p>
	<p>Remote alignment of sensor heads with SmarAct's STT mirror mount. A small aluminum spacer with 1/2" diameter can be attached for easy assembly in setups with strict space constraints.</p>
	<p>Manual alignment mount by using flexures and fine adjustment screws.</p>
	<p>Angular measurement assembly with three C01 sensor heads in a L-shaped configuration. Furthermore, a variant for C03 heads is available, which can be used together with a corresponding retro-reflector target assembly.</p>



Software and Graphical User Interface

Included with every PICOscale is an extensive software bundle with drivers, libraries, LabVIEW® VIs as well as a variety of supplementary documents. All functions of the device are explained in the PICOscale User Manual and the most common applications are explained in short User Guides. If you still need support, please do not hesitate to contact our well-trained technical sales team.

Every PICOscale is delivered with a graphical user interface to configure the device. All firmware modules can conveniently be addressed with a few clicks.

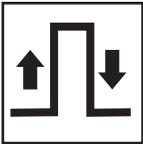
Furthermore, all data sources can be monitored in customizable panels. The data can be directly displayed in a time series or pre-processed to show spectra or spectral densities, for example.

Metrology

Measuring Displacements - Firmware Modules

Firmware Modules

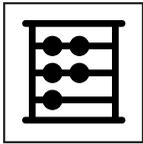
The **PICOSCALE** provides a number of unique firmware modules that can be linked almost arbitrarily. Ultra-fast response times are realized as all modules directly run on the controller itself to easily set up complex experiments without programming software code.



Advanced Trigger

Fast Trigger Pulse Processing for:

- Synchronization with master clock of external devices
- Triggered data acquisition
- Alert system in case of unforeseen events, e.g. loss of optical signal, to be used as an emergency stop of external motion systems



Calculation System

Real-time Data Processing for:

- Calculation of angles
- Scaling of results
- Output of position data via the GPIO interface within control loops
- Output of functions based on user defined look-up tables



Signal Generator

Arbitrary Function Generator for:

- Basic signal generator functionality (sine, square, sawtooth, custom)
- Excitation of targets and analysis of their frequency response with 1 mHz to 2.5 MHz



Clock Generator

Generate your Own System Clock for:

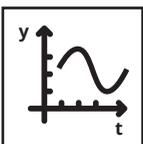
- Timing of internal or external processes
- Generation of periodic trigger events with 1 mHz to 10 MHz



Counter

Counter Module Used for:

- Counting of user defined trigger events
- Counting the clock pulses between trigger events
- Counting of system clock pulses for absolute timing of data



Stream Generator

Configuration of Data Stream to User PC:

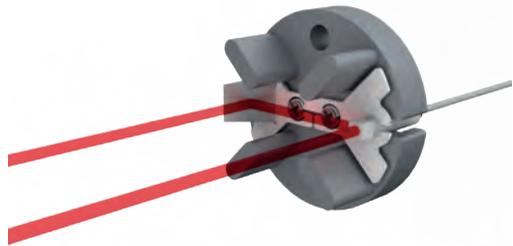
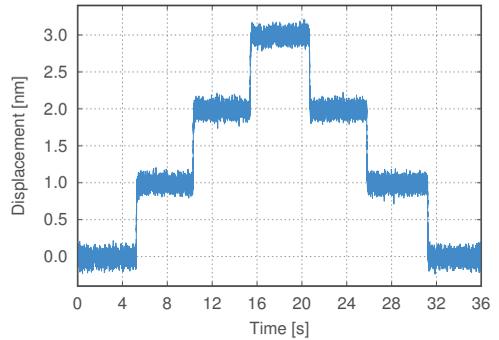
- Up to 10 MHz data rate
- Many options to filter data
- Connected to trigger module for synchronized data acquisition

Application Examples

PICOSCALE as Closed-loop Sensor

The MCS2 is SmarAct's most powerful modular control system. The PICOSCALE can be easily linked to the MCS2 as a displacement sensor. By using the interferometer's position data, the performance of closed-loop positioning can significantly be improved compared to standard sensor types. Furthermore, the results of the PICOSCALE Calculation System are available as data sources allowing for angular control, for example.

A PICOSCALE differential sensor head is used to track the position of a target mirror mounted on a SmarAct SLC1730 stage relative to another mirror mounted on the base. Due to the differential measurement, air fluctuations are intrinsically reduced. Using the PICOSCALE in combination with the MCS2 consequently allows for sub-nanometer closed-loop movements.



Setup for differential displacement measurement. The lower beam is aligned to the rigid base while the upper beam is reflected off a mirror attached to a moving slide.

Metrology

Measuring Displacements - Application Examples



Device Synchronization

Using the **PICO SCALE** advanced trigger module, internal and external events can be used to synchronize processes.

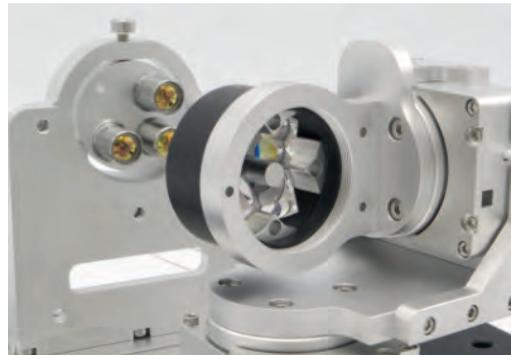
Accurate timing of the Interferometer's data with a master clock is obtained with a few clicks.

For example, we showed that the average output power of the interferometer can be reduced by two orders of magnitude for use in cryogenic applications. By using a fast optical switch with very small duty cycle, the interferometer position calculation was only active when the switch transmitted power to the setup. This flexibility cannot be found in any other system on the market.

Closed-Loop Angle Control

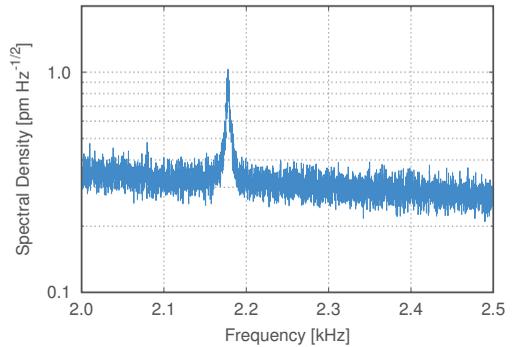
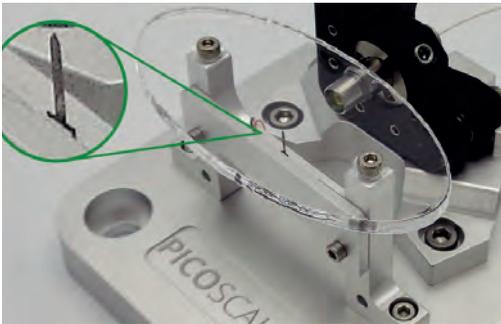
Three position channels are used in the **PICO SCALE Calculation System** to infer angular motions of a target. The output can be directly used as sensor data in a **MCS2 Controller** so that closed-loop angular positioning is possible without the need of a permanent user PC interface.

You achieve alignment and stabilization of components such as Laue lenses with interferometric accuracy.



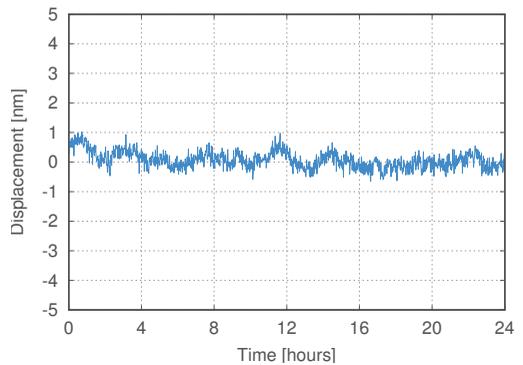
Vibration Measurement

A **PICOSCALE** sensor head is used to measure the thermally excited motion of a small cantilever. The spectral analysis of the displacement data reveal a single picometer oscillation amplitudes on a 300 fm / $\sqrt{\text{Hz}}$ noise floor.



Stability Measurement in Ambient Air

A sensor head and a target mirror are mounted on a metal block with a working distance of 20 mm. The displacement of the target mirror as well as the environmental parameters are recorded for a full day. After real-time correction for changes of the refractive index of air using the **PICOSCALE Environmental Module** and compensation for thermal drifts, the stability of the system is within 1 nm ($2\sigma = 563$ pm) in ambient air for this specific setup.



A **PICOSCALE** Sensor Head is aligned to a mirror. Both components are mounted on a rigid base plate.

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Measuring Displacements - Data and Signal Interfaces

Data and Signal Interfaces

The **PICOSCALE Interferometer** offers various methods to extract data. Connections to a user PC can be established via USB and/or Ethernet (multi-user ready).

Key Features	
USB and Ethernet	Data transfer to a user PC with up to 10 MHz data rate of all available data sources. Up to two connections at the same time.
Serial Data	Serial data transmission of displacement or <i>Calculation System</i> data.
AQuadB	Incremental transmission of displacement or <i>Calculation System</i> data.
Analog Inputs	3 analog-to-digital converters with up to 16 bit resolution accessible via the PICOSCALE Breakout Box .
Analog Output	5 digital-to-analog converters with up to 16 bit resolution accessible via the PICOSCALE Breakout Box .
Trigger Inputs/ Outputs	1 input at the controller front plate, 9 inputs/outputs accessible via the PICOSCALE Breakout Box .



PICOSCALE Breakout Box.

PICOSCALE Breakout Box

The optional **PICOSCALE Breakout Box** provides a simple and convenient access to the many different interfaces of the **PICOSCALE** controller. Analog and digital GPIOs can be accessed via BNC connectors while the DDI (AquadB or Serial Data) signals are mapped to D-Sub 15 connectors.

Key Features	
Digital 1-4	0 ... 5 V, rising/falling edge time < 50 ns
Digital 5-9	0 ... 3.3 V, rising/falling edge time < 50 ns
ADC 1	16 bit resolution, 10 MSa/s, bandwidth 2 MHz, ± 10 V input voltage
ADC 2, ADC 3	16 bit resolution, 100 kSa/s, bandwidth 40 kHz, ± 10 V input voltage
DAC 1	12 bit resolution, 10 MSa/s, bandwidth 2 MHz, ± 10 V output voltage
DAC 2-5	16 bit resolution, 200 kSa/s, bandwidth 150 kHz, ± 10 V output voltage
DDI Ch 1 - Ch 3	0 ... 5 V differential output
Power	12 V/250 mA source to supply external circuitry



PICO SCALE Environmental Module

The *Environmental Module* is an accessory product for the PICO SCALE. It monitors the environmental parameters such as temperature, relative humidity, and air pressure. With these data the PICO SCALE controller is able to correct the recorded displacement data online for changes in the refractive index of air and thus virtual drifts of the target mirror.

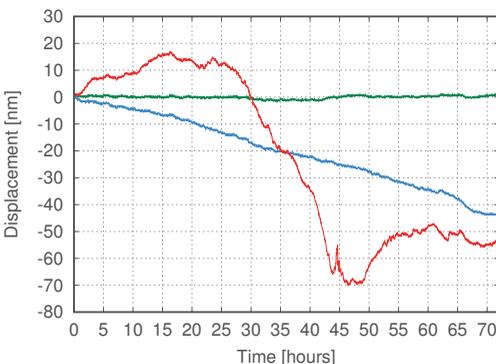
	Accuracy	Resolution
Temperature [°C]	0.5	0.01
Pressure [mbar]	1.5	0.02
Humidity [% RH]	1.8	0.04



PICO SCALE Temperature Box

The PICO SCALE *Temperature Box* is a powerful accessory for the PICO SCALE *Interferometer*. The *Temperature Box* provides ten channels to connect platinum temperature sensors, which can be very compact. The sensors can be mounted to very confined setups to perform local temperature measurements. Furthermore, the sensors can be directly used to measure the temperature of a material. Compensation for thermal expansion becomes more accurate because the data can be directly processed in the PICO SCALE *Calculation System*.

Key Features	
Number of Channels	10
Sensor Connection	M8 connectors
Measurement Mode	4-wire
Sensor Type	PT1000, Class A
Sensor Tolerance [°C]	0.15



Closed-Loop Position Correction

The PICO SCALE *Environmental Module* is used to record pressure, relative humidity and temperature of the ambient air of a setup, and consequently changes in the air's refractive index are corrected. The compact sensors of the PICO SCALE *Temperature Box* were attached to the experimental setup so that the thermal expansion coefficient was inferred. As the sensor data is available in the PICO SCALE *Calculation System*, the thermal expansion can also be subtracted immediately. The graph on the left shows the uncorrected position measured by the PICO SCALE *Interferometer* (red), the displacement with activated deadpath correction (blue), and the position corrected for thermal drift (green).



The **PICO SCALE Vibrometer** combines pm resolution interferometry with a 3D positioning system to provide a complete modal analysis of complex micromechanical devices.

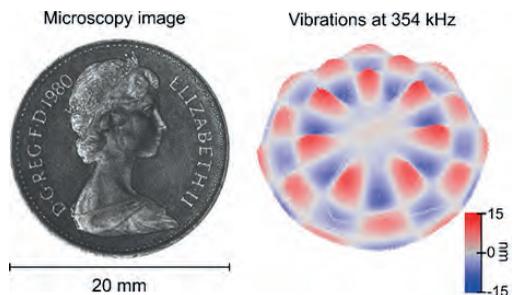


Imaging Vibrations

The PICOscale Vibrometer is designed for megapixel imaging of vibrational modes of structures like actuators, sensors and MEMS. This is achieved by raster-scanning a tightly focused laser beam of a Michelson interferometer over the sample to measure the vibrations for each pixel of the microscopic image. Vibrations in the sample can be induced by the advanced piezo-based shaker stage but also directly with an electrical signal that is generated by the PICOscale Vibrometer.

The use of SmarAct's closed-loop piezo positioners makes it possible to analyze structures with sizes from just a few μm up to 20 mm. A unique feature of the PICOscale Vibrometer is that the interferometer laser beam is used simultaneously to record a microscopy image of the sample. This microscopy image is thus intrinsically aligned with the vibration measurements and a separate microscope imaging system is not required.

The PICOscale Vibrometer is delivered as a turnkey system and includes an extensive software package for data acquisition and analysis.



Megapixel microscopy image of a coin (left image). The coin was excited with the shaker stage at 354 kHz and the resulting vibrations were recorded simultaneously at each pixel of the image, from which a vibration image can be reconstructed (right image).

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Measuring Vibrations - PICOscale Vibrometer

System Controller

The vibrometer controller hosts all the necessary optical components and electronics to generate an infrared laser beam and to detect the interference signal that is received from the sensor head. Furthermore, it contains the circuitry to convert the measured interferometric data into a position signal in order to extract frequency, amplitude and phase of the vibrations. The stage controller contains the electronics for operating the 3D positioning stage in closed-loop and to provide access to internal system signals through the different GPIO connectors. Additionally, it includes a high-bandwidth power amplifier to drive the shaker stage to enable modal analysis.

1 3D Positioner with Sensor Head

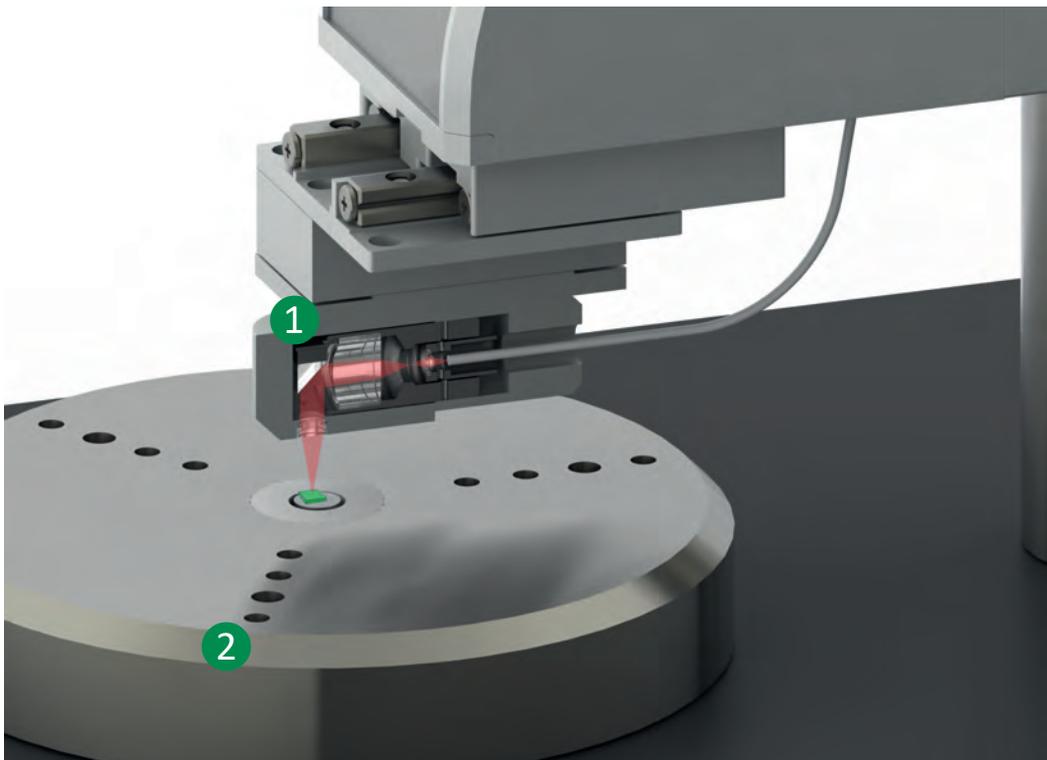
The 3D positioner is used to scan the interferometer over the region of interest. It is built around three SmarAct closed-loop positioners enclosed in a compact protective housing. The sensor head is mounted on the lowest positioner and contains a miniature Michelson interferometer with focusing

optics and is connected via a single-mode optical fiber to the vibrometer controller.

The 3D positioner with sensor head is mounted on a 25 mm diameter post so that its height is easily adjusted to accommodate samples of different dimensions. It is possible to remove the assembly from its mounting post in order to install it in a custom setup.

2 Shaker Stage

The shaker stage can be used to mechanically actuate a sample over a wide frequency range. It is based on a fast piezo based actuator mounted in a solid stainless steel housing and driven by the stage controller. To allow a reliable analysis of the dynamic characteristics of the sample, the shaker stage was optimized to deliver a smooth response by minimizing pronounced peaks in its amplitude spectrum.



Extensive Software Package

The **PICOSCALE Vibrometer** is delivered with two programs that can be operated in parallel:

1. The vibrometer control software is required to operate the instrument with a regular PC. An intuitive user interface allows to perform complicated measurements with a few mouse clicks.
2. The vibrometer view software is offered to analyze the recorded vibrometry data. It contains a variety of options to process the data for visualization optimization in 2D and 3D but also to export the recorded binary data file into formats that can be easily imported by third party software.



Key Features		
Vibration Measurements	Vibration Resolution in Single Point Mode [pm]	< 1
	Vibration Resolution in Imaging Mode [nm]	0.1
	Frequency Range [MHz]	Up to 2.5 ¹
Optical Microscope	Optical Lateral Resolution [µm]	2 ... 7 ²
	Working Distance [mm]	1.5 ... 10 ²
	Maximum Image Size [mm]	20 x 20
	Minimum Pixel Size [µm]	1
	Maximum Number of Pixels	1000 x 1000
Dimensions	Controller	2 units of each 33 x 27 x 7.2 cm (W x L x H), combined weight 7.6 kg
	Scanning Stage	5.5 x 11.0 x 7.5 cm (W x L x H), weight 0.25 kg
	Scanning Mount	Granite stone 15 x 20 x 4 cm (W x L x H) with stainless Steel post 2.5 x 15 cm (Ø x H), combined weight 4.3 kg
	Shaker Stage	Stainless Steel 8 x 1.5 cm (Ø x H), weight 0.5 kg

¹ lowest frequency in imaging mode is 50 Hz

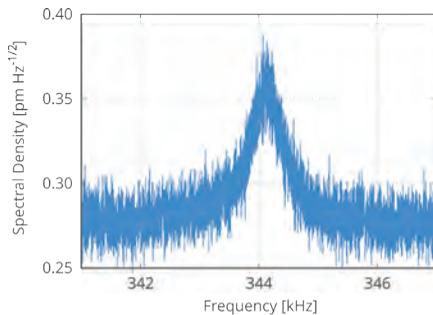
² depending on sensor head

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Measuring Vibrations - Application Examples

Characterizing Vibrations by FFT Analysis

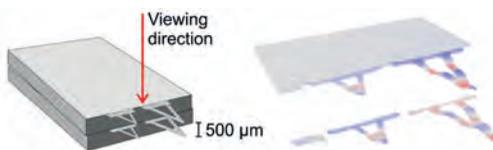
At each position of the imaged structure, the out-of-plane vibrations can be measured by interferometry. When a single or a few positions are measured on the sample, the data can be simply transformed into the frequency domain by a fast Fourier transform (FFT), which will reveal the frequency response at the measured positions. FFT plots consisting of up to 2.5 million data points can be recorded with the **PICOSCALE Vibrometer**, which allows a high-resolution analysis of the recorded spectra.



FFT plot showing the amplitude spectrum of a micro cantilever measured at a single position. Although the cantilever was not actively excited, the high resolution of the interferometric measurements still allows to detect the thermal fluctuations, in this case 0.36 µm at 344 kHz.

Optical Sectioning with Confocal Microscopy

The sensor head employs a confocal measurement principle: only light reflected from the focal plane will be detected while all out-of-focus light is

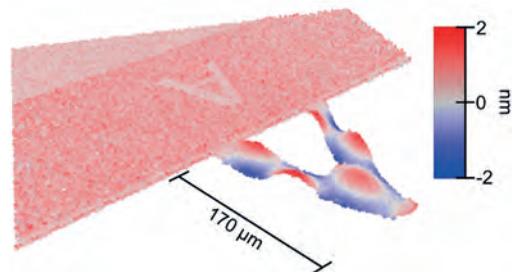


Measuring vibrations of multi-layered samples. Two AFM cantilever chips were positioned on top of each other such that the view on the lower cantilevers was blocked by the upper ones. By confocal imaging of each of the layers, the vibrations can still be clearly resolved.

suppressed. This results in a higher signal-to-noise ratio of both the microscopy and vibration data. Furthermore, it becomes possible to image through semi-transparent materials and to image samples that are partly hidden by other objects, a feature that is especially useful when investigating structures that consist of multiple layers.

Recording Megapixel Vibration Images with a Lock-in Amplifier

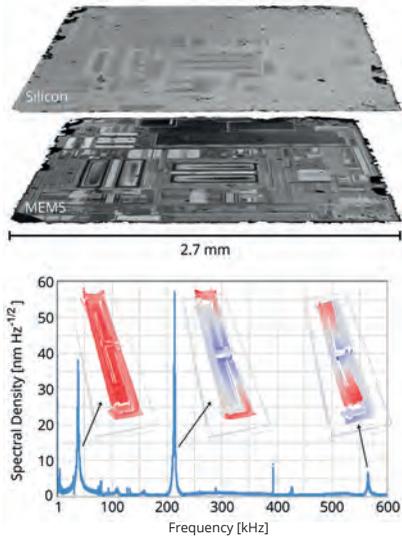
When a high number of positions on a structure need to be measured, the recording of individual FFT spectra becomes impractical due to the very high amounts of data that need to be processed. To overcome this, the **PICOSCALE Vibrometer** is equipped with a dual-phase lock-in amplifier. Basically, the lock-in amplifier extracts the amplitude and phase at one specific frequency from the measured data and thereby reduces the amount of data to just two values. Finally, the use of a lock-in amplifier allows on-the-fly analysis of the vibrations. It is thus possible to record vibration images while quickly raster-scanning the measurement laser over the region of interest. This reduces the recording time of images with a high number of pixels enormously.



3D deflection plot of a micro cantilever that was excited at 2.1 MHz. The plot was reconstructed from the amplitude and phase information that was obtained by the lock-in amplifier.

Measuring MEMS through Silicon with an Infrared Measurement Laser

All **PICOSCALE** products are based on an infrared 1550 nm laser source. A unique advantage of using such wavelength is that it allows to 'look' through materials that are non-transparent for visible light such as silicon. Nevertheless, when the measurement laser is focused on a silicon

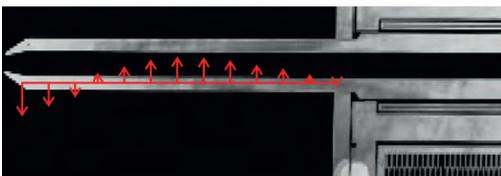


Measuring vibrations of MEMS through a packaging of silicon is made possible by confocal imaging with an IR light source. We thank InvenSense, a TDK Group Company, for their support with this application example.

structure, the reflection is still high enough to record a microscopic image and to measure the vibration of the structure.

Measuring Lateral Vibrations

With the interferometric measurement principle only out-of-plane vibrations (parallel to the optical axis) can be measured. To enable the measurement of in-plane vibrations (perpendicular to the optical axis) a module has been developed that records a sequence of microscopic images that span a single vibration cycle (conceptionally similar to stroboscopic imaging). Through optical flow algorithms, in-plane vibrations as small as 10 nm can be extracted from laterally moving parts of the sample.



Measuring lateral vibrations. With a tracking routine the in-plane motion of selected parts of the imaged microgrippers can be measured.

Integration in Custom Setups

The sensor head is combined with the 3D positioner in a compact assembly. This makes it possible to integrate the vibrometer in custom setups and even in vacuum chambers (upon request). The use of SmarAct's motor technology makes it possible to position the laser beam with very high accuracy at any part of the sample. This can be used to measure vibrations at specific points on the sample at very high resolution, for example to reveal sub-µm vibrations.



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